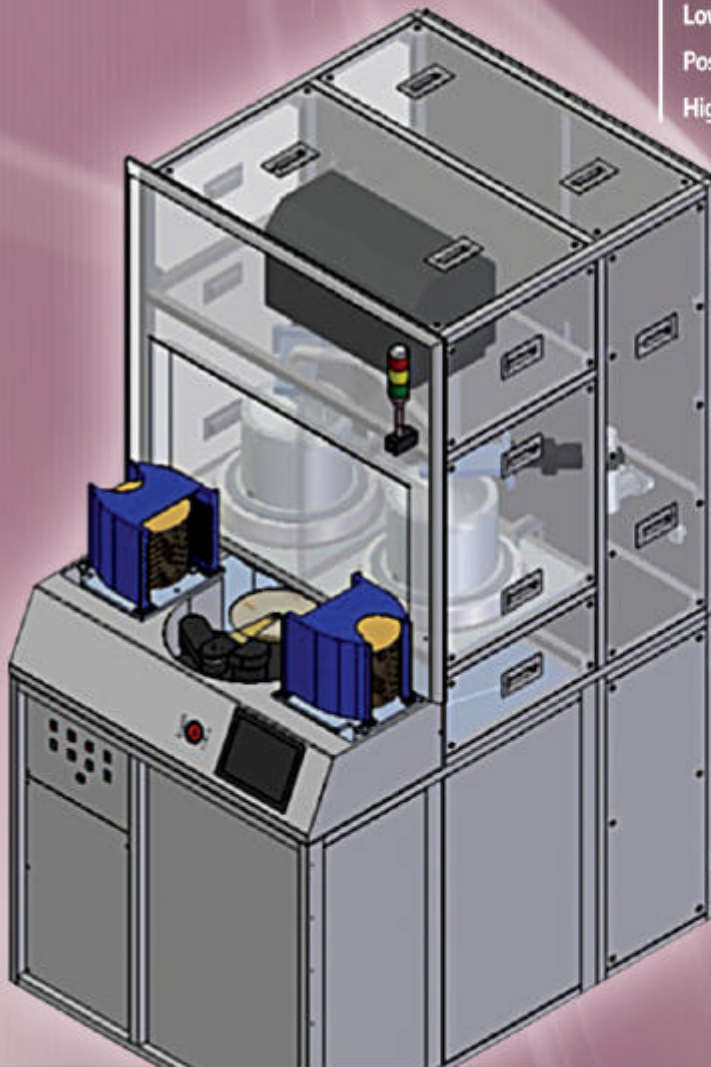


RRG Ashing / Etching System

System Advantages

- Simple Hardware & Easy Maintenance
- Downstream Remote Radical Generation
- Wide Process window
- Low Plasma damage and Low CoO
- High Ashing Rate, High Throughput and Good Uniformity
- Low-k Ashing (Damascene Process)
- Post-Etch Ashing & Dry Cleaning
- High Dose Implant Strip



TERATECH

Tera Tech Co., Ltd.
(주) 테라텍

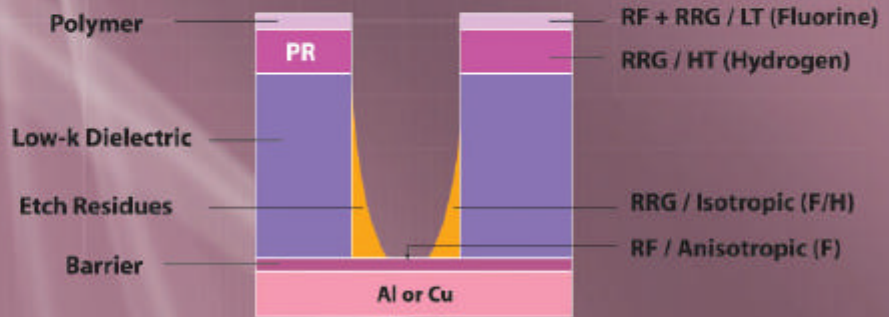
456-821 경기도 안성시 공도읍 용두리 529

529 Yeongdoo-Ri, Gongdo-Eup, Anseong-Si, Kyounggi-Do, Korea.

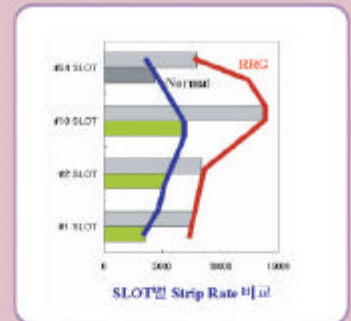
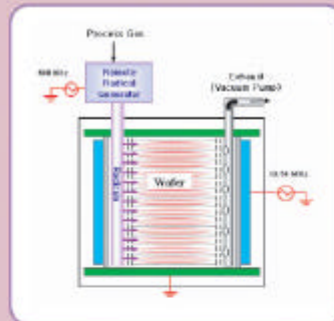
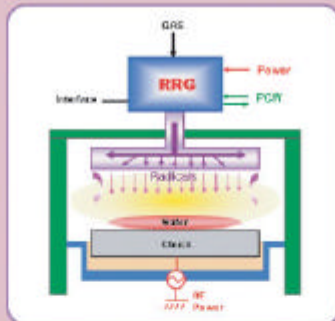
TEL. +82-31-653-8360 F. +82-31-653-8361 (www.semitera.com)

RRG Ashing / Etching System

Low-K Ashing & Cleaning



Concept & Performance



RRG Asher Modification

